

XA-10436
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

NISHIZAWA, Hirotaka et al.

Intl. Appln. No.: PCT/JP2004/013929

Intl. Filing Date: 24 September 2004

For: SEMICONDUCTOR DEVICE

* * *

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Attn: Mail Stop PCT, DO/EO/US

Sir:

Pursuant to 37 C.F.R. § 1.56, and without any assertion as to materiality or prior art effect, the documents listed on the attached Form PTO-1449 are hereby cited.

The document on the attached List was cited in the specification, on pages 1-2, and its relevance is indicated therein.

Respectfully submitted,

MWS:sjk

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By: 

Mitchell W. Shapiro
Reg. No. 31,568

September 23, 2005

FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT LIST OF DOCUMENTS CITED BY APPLICANT				Atty. Docket No. XA-10436		Appln. No. 10/550578	
				Applicant NISHIZAWA, Hirotaka et al.			
				Filing Date HEREWITH		Group	
U.S. PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Name	Class	Sub-class	Filing Date
	AA						
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FOREIGN PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Country	Class	Sub-class	Translation
	AE	2000-99215	04/07/00	Japan			Yes
	AF						
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